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2817
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of

Akio KITAMURA

Serial No.: 10/055,722

Group Art Unit: 2811

Filed: January 23, 2002

Examiner:

For: SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE AND
MANUFACTURE METHOD THEREFORE

Certificate of Mailing

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Date: 03/31/04
By: [Signature]
Marc A. Rossi

**REQUEST FOR ACKNOWLEDGMENT
OF INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents
P.O. Box 1450, Alexandria, VA 22313-1450

Sir:

Applicant hereby requests that the Patent Office acknowledge the receipt of the
Information Disclosure Statement filed on January 23, 2002 for the above-referenced application.
For the convenience of the Patent Office, a copy of the Information Disclosure Statement, the
PTO Form-1449 and the stamped Receipt Card are enclosed. It is respectfully requested that an
initialed copy of the PTO-1449 be returned to the undersigned.

Respectfully submitted,

ROSSI & ASSOCIATES

[Signature]
Marc A. Rossi
Registration No. 31,923

03/31/04
Date

Attorney Docket No. FUJI:203

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akio KITAMURA

Serial No.: NEW APPLICATION

Filed: January 23, 2002

For: SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE AND
MANUFACTURE METHOD THEREFORE



Batch:

Group Art Unit:

Examiner:

COPY

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. Copies of the references listed on Form PTO-1449 are attached.

It is respectfully requested that the information be expressly considered during the prosecution of this application, that these references be made of record therein and appear among the "References Cited" on any patent to issue therefrom, and that an initialed copy of the PTO-1449 be returned to the undersigned.

Respectfully submitted,

Date: 01/23/02

A handwritten signature in black ink, appearing to read "Marc A. Rossi", written over a horizontal line.

Marc A. Rossi
Registration No. 31,923

Attorney Docket No.: FUJI:203

ROSSI & ASSOCIATES
P.O. Box 826
Ashburn, VA 20146-0826

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

APR 01 2004

Docket Number (Optional)
FUJI:20.

Application Number
NEW APPLICATION

Applicant(s)
Akio KITAMURA

Filing Date
January 23, 2002

Group Art Unit

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

COPY

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	JP	60-10780	1/85	JAPAN (English Abst.)			✓	
	JP	60-105277	6/85	JAPAN (English Abst.)			✓	
	JP	61-190983	8/86	JAPAN (English Abst.)			✓	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



USPT RECEIPT CARD In re application of:

Akio KITAMURA

Batch:



Serial No.: NEW APPLICATION Group Art Unit:

Filed: January 23, 2002

Examiner:

For: SEMICONDUCTOR INTEGRATED CIRCUIT
DEVICE AND MANUFACTURE METHOD
THEREFORE

Papers Filed: NEW APPLICATION; SPECS. 20 PGS.;
FIGS. 1-14; IDS; PRIORITY

Attorney Docket: FUJI:203